

<b>Notice of References Cited</b>	Application/Control No. 10/002,483	Applicant(s)/Patent Under Reexamination CARR	
	Examiner Allan Olsen	Art Unit 1763	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Takino et al., Computer Numerically Controlled Plasma Chemical Vaporization Machining with a Pipe Electrode for Optical Fabrication, Applied Optics, Vol. 37, No. 22, pages 5198-5210, August 1, 1998
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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